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**RESPONSE UNDER 37 C.F.R.  
§1.116 EXPEDITED PROCEDURE  
EXAMINING GROUP 2891**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Shinya Ito	Examiner:	Asok K. Sarkar
Serial No:	10/763,315	Art Unit:	2891
Filed:	January 23, 2004	Docket:	17381
For:	SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME	Dated:	April 13, 2006

**Confirmation No. 7794**

Mail Stop AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 CFR § 1.116**

Sir:

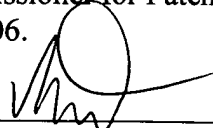
In response to the final office action of December 28, 2005, the Applicants submit the following response.

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**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Mail Stop AF, P.O. Box 1450, Alexandria, VA 22313-1450, on April 13, 2006.

Dated: April 13, 2006

  
Richard J. Danyko